

REMARKS

At the outset, the Examiner is thanked for the thorough review and consideration of the pending application. The Office Action dated April 20, 2005, has been received and its contents carefully reviewed.

Claims 1-8, 17, and 18 have been withdrawn. Applicants thank the Examiner for allowing claims 9-16. Claim 19 is hereby amended. Reexamination and reconsideration of the pending claims is respectfully requested.

The Examiner rejects claim 19 under 35 U.S.C. §102(e) as being anticipated by U.S. Patent 6,678,030 to Imabayashi. The '030 patent does not disclose the feature of "forming at least two groups of column spacers, in different areas from each other, on one of the thin film transistor substrate and the color film substrate, wherein a height and a diameter of the at least one group of the column spacers is different from those of the other group of the column spacers; and bonding the thin film transistor substrate and the color filter substrate to each other" recited in amended claim 19 of the present invention.

Applicants believe the foregoing amendments place the application in condition for allowance and early, favorable action is respectfully solicited.

If for any reason the Examiner finds the application other than in condition for allowance, the Examiner is requested to call the undersigned attorney at (202) 496-7500 to discuss the steps necessary for placing the application in condition for allowance. All correspondence should continue to be sent to the below-listed address.